

PATENT  
81784.0329

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Seiji KAI et al.

Serial No: 10/533,030

Filed: April 26, 2005

For: Method for Manufacturing Micro  
Lenses including Underlayer Film  
and Lens Film Etching Steps (as  
amended)

Art Unit: 2818

Examiner: Lopez Esquerro, Andres

I hereby certify that this correspondence is  
being transmitted via electronic filing to:

Mail Stop RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450 on

August 29, 2008

Date of Deposit

Nancy Nolen

Name

Signature  08/29/2008

Date

**PETITION FOR EXTENSION OF TIME**

Mail Stop RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

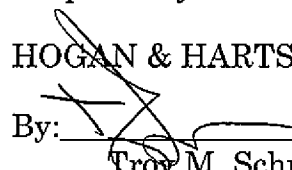
In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the Commissioner for a one-month extension of time extending to August 29, 2008, the period for response to the final Office Action dated April 29, 2008. Please charge the fee of \$120.00 for this extension to Deposit Account No. 50-1314. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-1314.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: August 29, 2008

By:   
Troy M. Schmelzer  
Registration No. 36,667  
Attorney for Applicant(s)

1999 Avenue of the Stars, Suite 1400  
Los Angeles, California 90067  
Telephone: 310-785-4600  
Facsimile: 310-785-4601